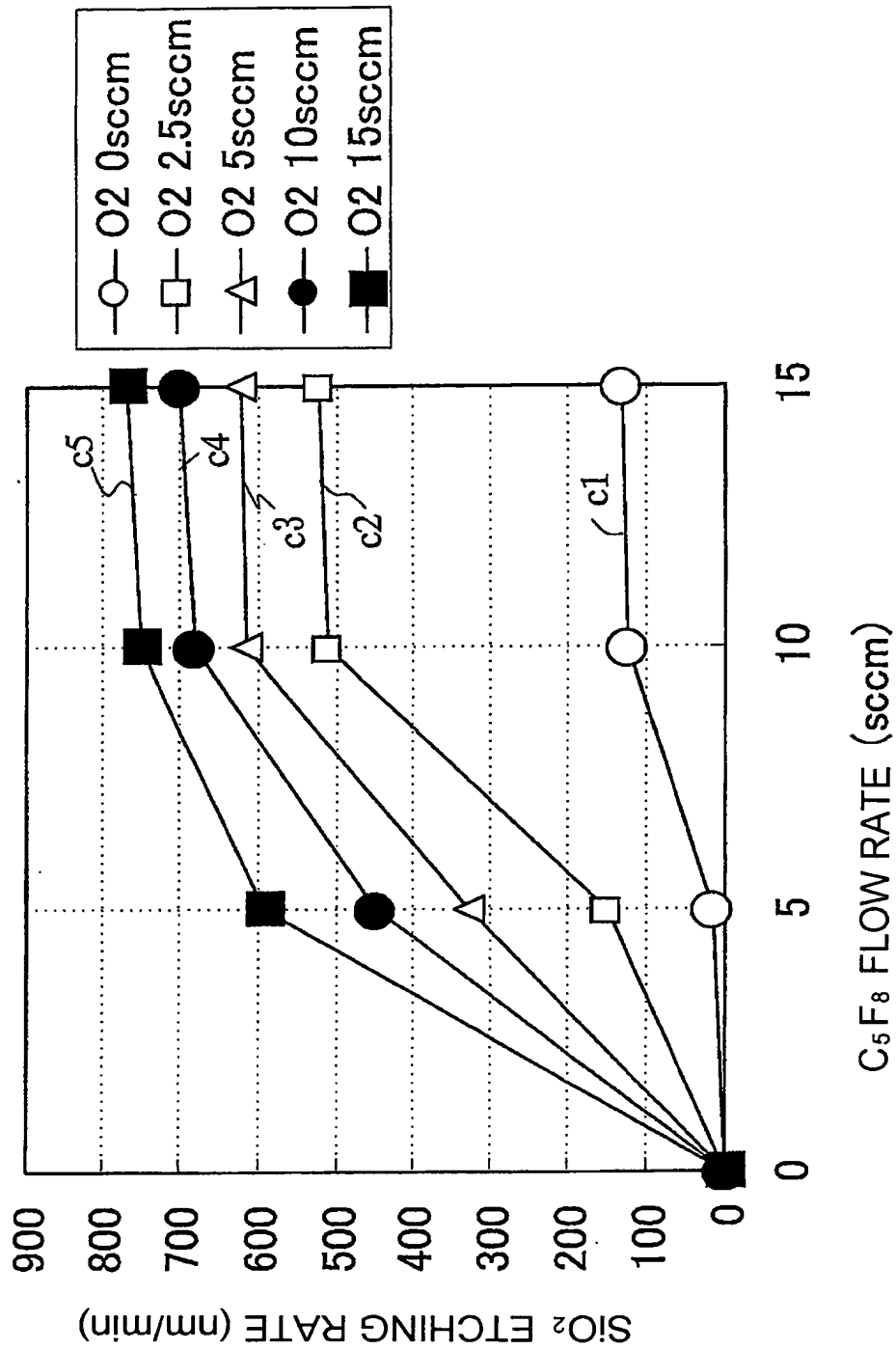
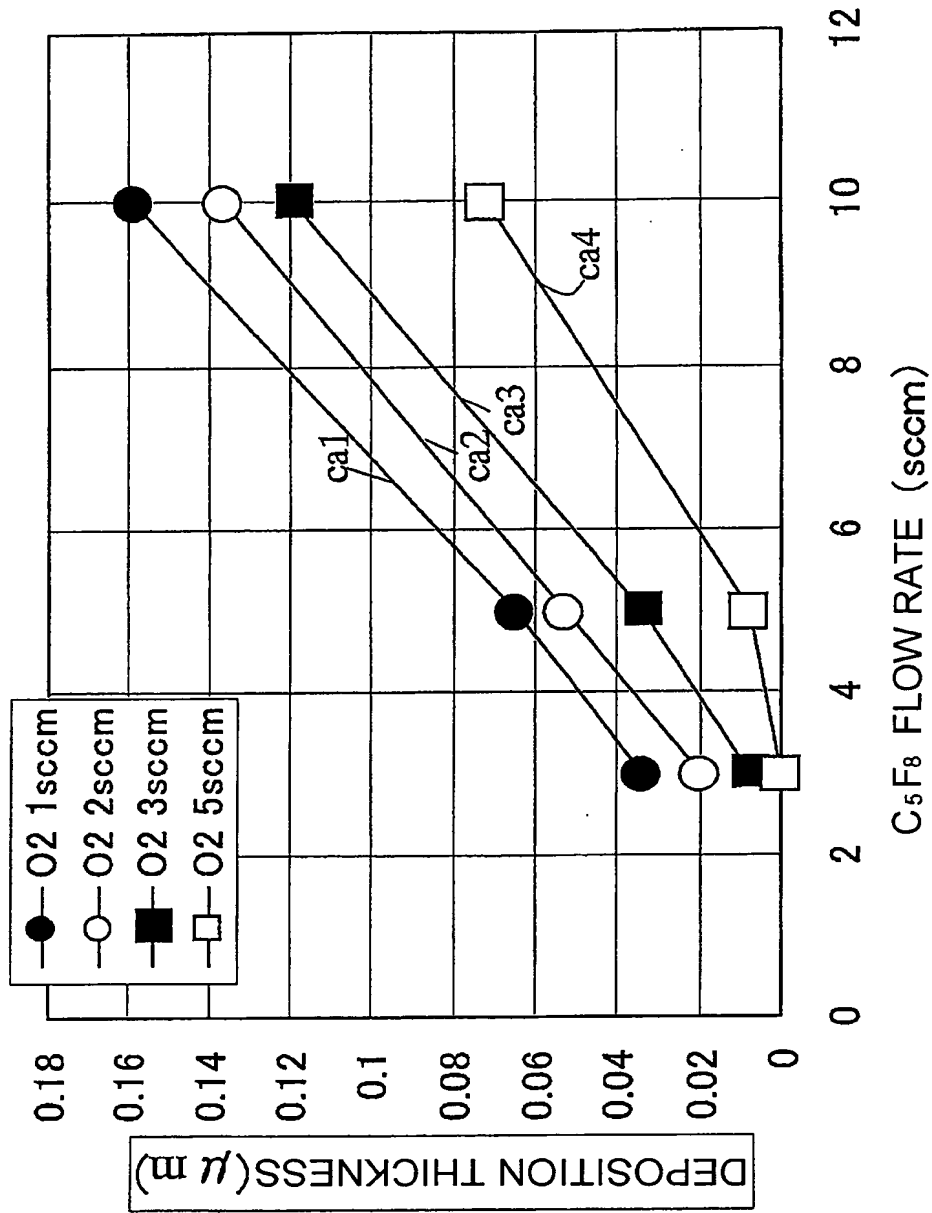


[FIG. 1]

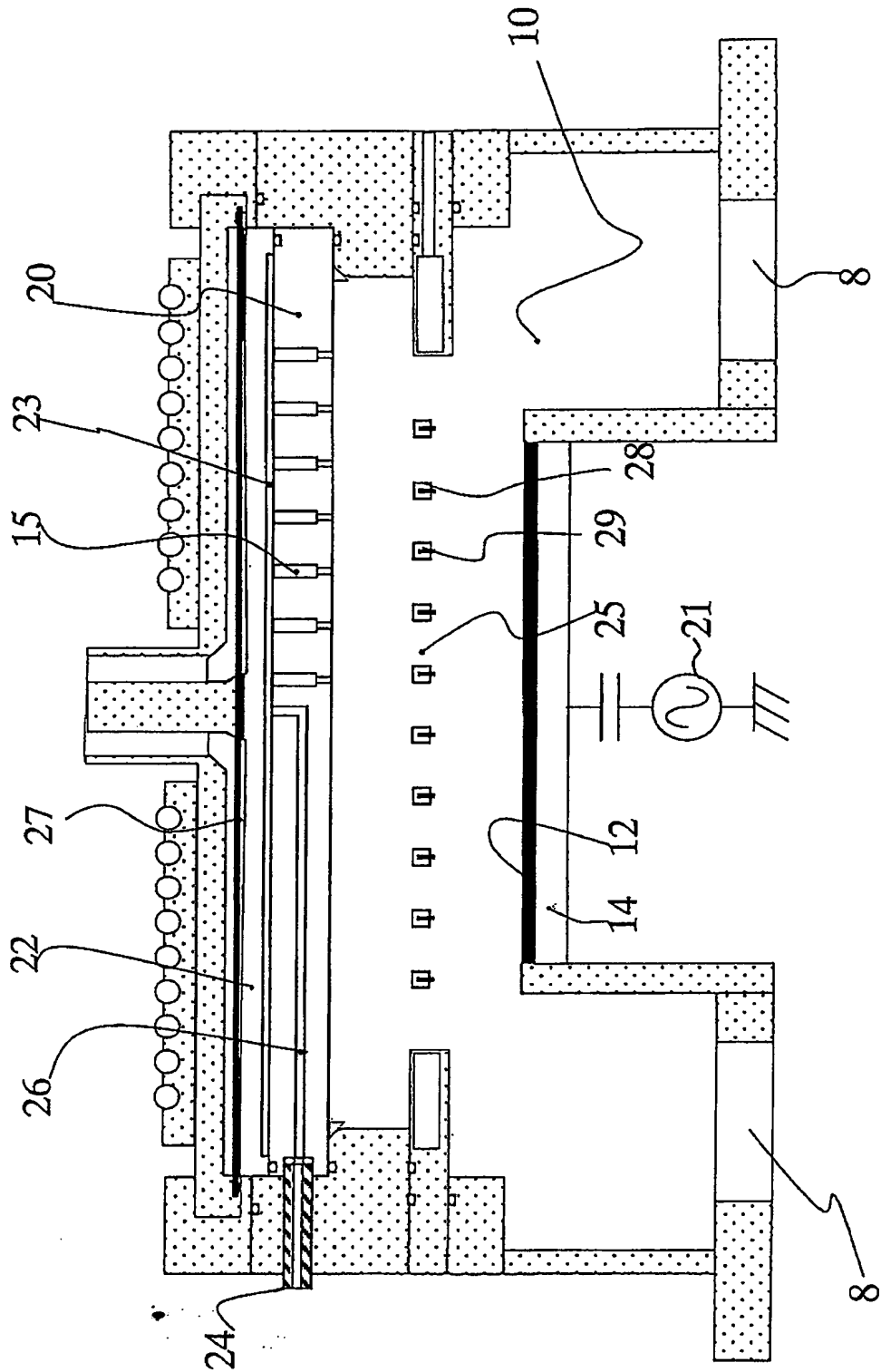


[FIG. 2]

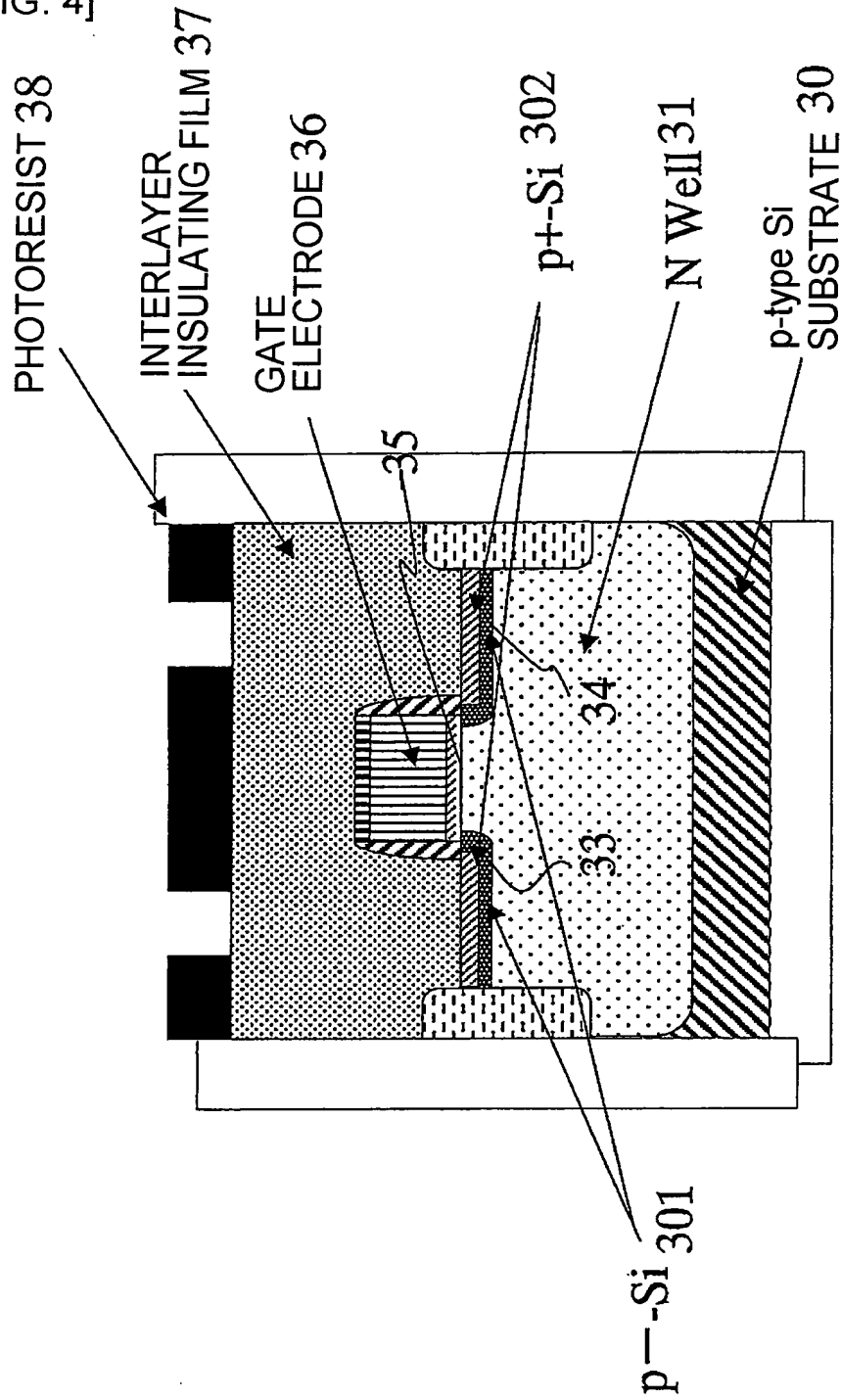


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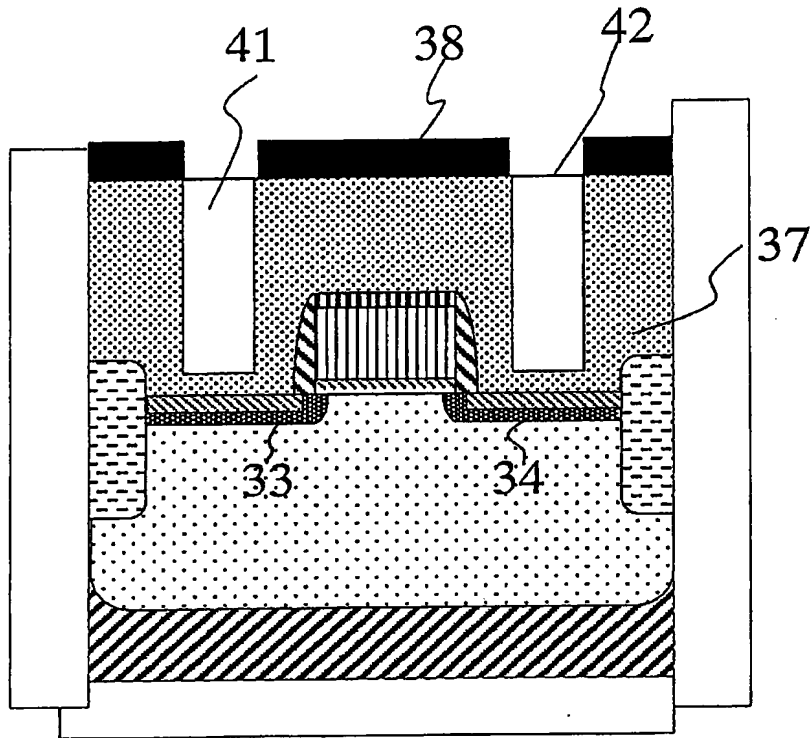
[FIG. 3]



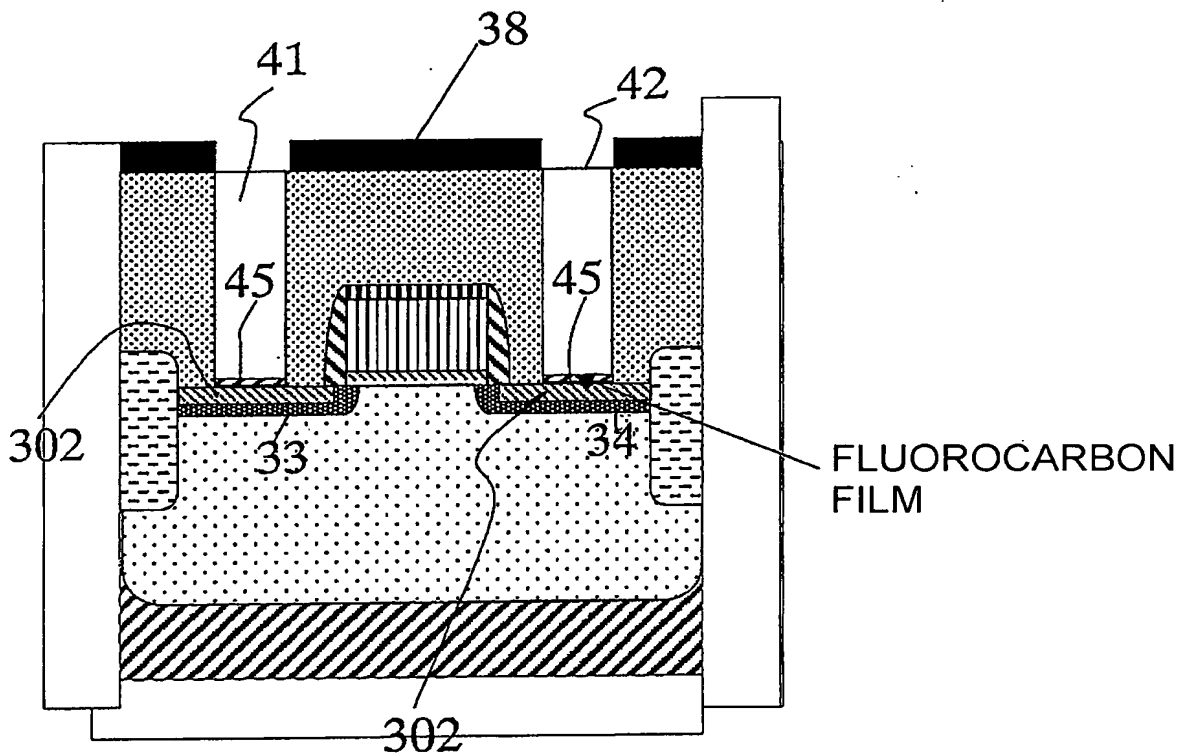
[FIG. 4]



[FIG. 5]



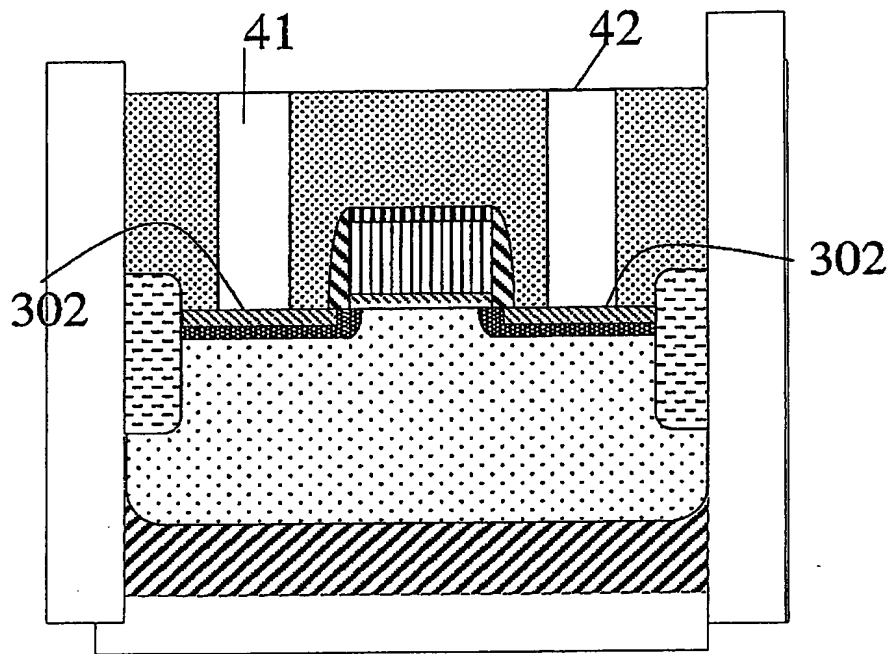
[FIG. 6]



Title: METHOD OF MANUFACTURING A
SEMICONDUCTOR DEVICE AND
METHOD OF ETCHING AN INSULATING
FILM

Inventor(s): Tadahiro OHMI, et al
DOCKET NO.: 039262-0156

[FIG. 7]



[FIG. 8]

